

Appl. No. 10/810,309
Amdt. Dated November 29, 2006
Reply to Final Office Action of September 19, 2006

Attorney Docket No. 81716.0122
Customer No. 26021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Isamu AKASAKI et al.
Serial No.: 10/810,309
Confirmation No.: 8006
Filed: March 26, 2004
For: SEMICONDUCTOR APPARATUS,
METHOD FOR GROWING NITRIDE
SEMICONDUCTOR AND METHOD
FOR PRODUCING
SEMICONDUCTOR APPARATUS

Art Unit: 2814

Examiner: Thao X. Le

I hereby certify that this correspondence is
being transmitted via facsimile to:
(571) 273-8300:

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on

November 29, 2006

Date of Deposit

Diane Zynn

Name

Signature

11/29/06

Date

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated September 19, 2006, please
amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.